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Substitute for form 1449A/PTO INFORMATION DISCLOSURE STATEMENT BY APPLICANT (use as many sheets as necessary)				Complete if Known	
				Application Number	10/798,584
				Filing Date	March 10, 2004
				First Named Inventor	Se-Hwan SON et al.
				Art Unit	1794
				Examiner Name	Marie Rose YAMNITZKY
Sheet	1	of	1	Attorney Docket Number	29137.317.00

U.S. PATENT DOCUMENTS					
Examiner Initials*	Cite No. ¹	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number-Kind Code ² (if known)			
	AA	7,052,351	05-30-2006	Tutt et al.	
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		Country Code ³ -Number ⁴ -Kind Code ⁵ (if known)				
	BA	WO 03/060956 A2	07/24/2003	LG Chem, Ltd.		
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OTHER PRIOR ART – NON PATENT LITERATURE DOCUMENTS			
Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
	CA	GU et al., "Transparent organic light emitting devices," Applied Physics Letters, vol. 68, No. 19, May 6, 1996, American Institute of Physics, 1996, 3 pgs.	
	CB	PARTHASARATHY et al., "A metal-free cathode for organic semiconductor devices," Applied Physics Letters vol. 72, No. 17, April 27, 1998, American Institute of Physics, 1998, 3 pgs.	
	CC	HUNG et al., "Interface engineering in preparation of organic surface-emitting diodes,," Applied Physics Letters, vol. 74, no. 21, May 24, 1999, American Institute of Physics, 1999, 3 pgs.	
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant

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